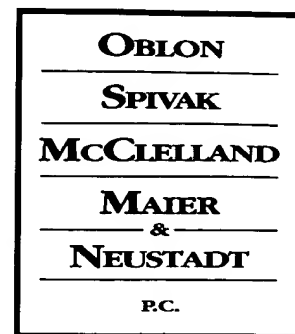




Docket No.: 214814US0

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231



ATTORNEYS AT LAW

RE: Application Serial No.: 09/975,262  
Applicants: Naomichi MIYAKAWA  
Filing Date: October 12, 2001  
For: METHOD FOR PRODUCING A SILICON NITRIDE  
FILTER  
Group Art Unit: 1731  
Examiner: FIORILLA

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SIR:

Attached hereto for filing are the following papers:

**Amendment + Marked-Up Copy; In re Antonie, 195 USPQ 6**

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
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